



In re Application of:

TADAHIRO OHMI ET AL.

Application No.: 09/985,707

Filed: November 6, 2001

For: LASER GAS SUPPLY PATH STRUCTURE
IN AN EXPOSURE APPARATUS
(AS AMENDED)

Docket No. 03500.013974.1

Examiner: Davienne N. Monbleau

Group Art Unit: 2828

Date: August 26, 2002

THE COMMISSIONER FOR PATENTS
Washington, D.C. 20231

Sir:

Transmitted herewith is an amendment in the above-identified application.

☐ No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 6	MINUS	** 20	= 0	x \$9 \$18	.00
INDEP. CLAIMS	* 4	MINUS	*** 3	= 1	x \$42 \$84	\$ 84.00
Fee for Multiple Dependent claims \$140°/\$280						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$ 84.00

- * If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.
** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.



- ☒ A check in the amount of \$ 84.00 is enclosed.
- ☐ Charge \$ _____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
- ☒ A check in the amount of \$ 110.00 to cover the fee for a ONE month extension is enclosed.
- ☐ A check in the amount of \$ _____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Registration No. 24947

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35.C13974 D1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TADAHIRO OHMI, ET AL.) Examiner: Not Yet Assigned
Divisional of) Group Art Unit: N.Y.A.
Application No.: 09/425,015)
Filed: Herewith)
For: EXPOSURE APPARATUS, AND)
DEVICE PRODUCTION METHOD) November 5, 2001
(As Amended)

Commissioner for Patents
Washington, D.C. 20231

PRELIMINARY AMENDMENT

Sir:

Prior to examination on the merits, please amend the above-identified application as follows:

IN THE TITLE:

Please delete "GAS SUPPLY PATH STRUCTURE, GAS SUPPLY METHOD, LASER OSCILLATING APPARATUS, EXPOSURE APPARATUS, AND DEVICE PRODUCTION METHOD" and insert ~~EXPOSURE APPARATUS, AND~~ DEVICE PRODUCTION METHOD".

IN THE SPECIFICATION:

Page 1, line 2, insert the following new paragraph:

CONTINUING DATA

This application is a division of Application No. 09/425,015, filed October 25, 1999, pending.